



ECE606: Solid State Devices Lecture 14: Bulk Recombination

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Outline

- 1) Derivation of SRH formula
- 2) Application of SRH formula for special cases
- 3) Direct and Auger recombination
- 4) Conclusion

Ref. ADF, Chapter 5, pp. 141-154

Sub-processes of SRH Recombination



(1)+(3): one electron reduced from Conduction-band & one-hole reduced from valence-band

(2)+(4): one hole created in valence band and one electron created in conduction band

SRH Recombination

Physical picture



Equivalent picture



(1)+(3): one electron reduced from C-band & one-hole reduced from valence-band

(2)+(4): one hole created in valence band & one electron created in conduction band







Expressions for (n_1) and (p_1) $n_{T0} = N_T \left(1 - f_{00} \right) = \frac{N_T}{1 + \varrho_F e^{\beta(E_T - E_F)}}$ $n_{1} = \frac{n_{0} p_{T0}}{n_{T0}} = n_{0} \frac{\left(N_{T} f_{00}\right)}{N_{T} \left(1 - f_{00}\right)}$ $p_1 n_1 = n_{,}^2$ $n_{1} = n_{i}e^{\beta(E_{F}-E_{i})}\left[1 + g_{D}e^{\beta(E_{T}-E_{F})} - 1\right]$ $p_1 = n_i^2 / n_1$ $= n_i g_D e^{\beta(E_T - E_i)}$ $= n_i g_D^{-1} e^{\beta (E_i - E_T)}$

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Dynamics of Trap Population



$$\frac{\partial n_T}{\partial t} = -\frac{\partial n}{\partial t} \bigg|_{1,2} + \frac{\partial p}{\partial t} \bigg|_{3,4}$$

$$= c_{n} n p_{T} - e_{n} n_{T} - c_{p} p n_{T} + e_{p} p_{T}$$
$$= c_{n} (n p_{T} - n_{T} n_{1}) - c_{p} (p n_{T} - p_{T} p_{1})$$



$$\frac{\partial n_T}{\partial t} = 0 = c_n \left(n p_T - n_T n_1 \right) - c_p \left(p \ n_T - p_T p_1 \right)$$

$$n_{T} = \frac{c_{n}N_{T}n + c_{p}N_{T}p_{1}}{c_{n}(n + n_{1}) + c_{p}(p + p_{1})} = c_{n}(np_{T} - n_{T}n_{1})$$

Net Rate of Recombination-Generation





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Case 1: Low-level Injection in p-type

$$R = \frac{np - n_i^2}{\tau_p (n + n_1) + \tau_n (p + p_1)}$$

$$= \frac{(n_0 + \Delta n)(p_0 + \Delta n) - n_i^2}{\tau_p (n_0 + \Delta n + n_1) + \tau_n (p_0 + \Delta p + p_1)}$$

$$= \frac{\Delta n(n_0 + p_0) + \Delta n^2}{\tau_p (n_0 + \Delta n + n_1) + \tau_n (p_0 + \Delta p + p_1)}$$

$$= \frac{\Delta n(p_0)}{\tau_n (p_0)} = \frac{\Delta n}{\tau_n}$$

$$\Delta n^2 \approx 0$$

$$p_0 \gg \Delta n \gg n_0$$
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Case 2: High-level Injection

$$R = \frac{np - n_i^2}{\tau_p (n + n_1) + \tau_n (p + p_1)}$$
e.g. organic solar cells

$$= \frac{(n_0 + \Delta n)(p_0 + \Delta p) - n_i^2}{\tau_p (n_0 + \Delta n + n_1) + \tau_n (p_0 + \Delta p + p_1)}$$

$$= \frac{\Delta n (n_0 + p_0) + \Delta n^2}{\tau_p (n'_0 + \Delta n + n_1) + \tau_n (p_0 + \Delta n + p_1)}$$

$$= \frac{\Delta n^2}{(\tau_n + \tau_p)\Delta n} = \frac{\Delta n}{(\tau_n + \tau_p)}$$

$$\Delta n \gg p_0 \gg n_0$$



Case 3: Generation in Depletion Region

$$R = \frac{np - n_i^2}{\tau_p \left(n + n_1\right) + \tau_n \left(p + p_1\right)}$$





 $n \ll n_1 \quad p \ll p_1$

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Band-to-band Recombination

$$R = B\left(np - n_i^2\right)$$

Direct recombination at low-level injection

$$n_0 \ll \left(\Delta n = \Delta p\right) \ll p_0$$

$$R = B\left[\left(n_0 + \Delta n\right)\left(p_0 + \Delta p\right) - n_i^2\right] \approx Bp_0 \times \Delta n$$

Direct generation in depletion region

$$n, p \sim 0$$
$$R = B\left(np - n_i^2\right) \approx -Bn_i^2$$



Auger Recombination

$$\sum_{n=0}^{\infty} 2 \text{ electron \& 1 hole}$$

$$R = c_n \left(n^2 p - n_i^2 n \right) + c_p \left(n p^2 - n_i^2 p \right)$$

$$c_n, c_p \sim 10^{-29} \text{ cm}^6/\text{sec}$$

Auger recombination at low-level injection

$$n_0 \ll \left(\Delta n = \Delta p\right) \ll \left(p_0 = N_A\right)$$



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Effective Carrier Lifetime with all Processes 10⁵ 10^{-2} Electron Lifetime in ns $\tau_{\text{R-G center}} = 10^{-3} \sec \theta$ 10³ 10^{-3} o Beck [7] 10^{-4} sec Dziewior [8] 10^{-4} 10 Iles (9) Misiakos [3] 10^{-5} sec 10^{-5} $\tau_{\rm n}, \tau_{\rm p}$ (sec) Swirhun [11] Best Fit 0.1 - 10^{-6} sec 10^{-6} 10^{17} 10^{18} 10^{19} 10^{20} Acceptor Concentration in cm⁻³ 10¹⁸ 10¹⁹ 10¹⁶ 1021 105 10^{-7} p-type n-type 10^{-8} Hole Lifetime in ns 10³ Beck [7] Burk [1] 10-9 10¹⁹ 1016 1017 1018 1014 10^{2} 1015 Dziewior [8] N_D Iles [9] 10 Misiakos [3] Wieder [10] $\tau_{eff} \approx c_{n,auger} N_D^{-2}$ Wang [5] Best Fit 0.1 10¹⁹ 10¹⁸ 1021 1020 1017 1016 Donor Concentration in cm⁻³ $\tau_{eff} = \left(c_n N_T + B N_D + c_{n,auger} N_D^2\right)^{-1}$ Elec. Dev. Lett., 12(8), 1991. 21

Conclusion

SRH is an important recombination mechanism in important semiconductors like Si and Ge.

SRH formula is complicated, therefore simplification for special cases are often desired.

Direct band-to-band and Auger recombination can also be described with simple phenomenological formula.

These expressions for recombination events have been widely validated by measurements.